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Docket No.
448563/0157
LR:DMF:GSP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hiroaki Sekizawa
Serial No. : 09/226,332
Filed : January 6, 1999
For : MACHINE MONITOR SYSTEM, LOCAL MONITOR
UNIT, INTEGRATED MONITOR UNIT, MACHINE
MONITOR METHOD, AND COMPUTER-READABLE
MEDIUM STORING PROGRAM

April 12, 2001

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant respectfully submits this Supplemental Information Disclosure Statement ("IDS") pursuant to 37 C.F.R. §§1.97 and 1.98 in order to comply with the duty of disclosure under 37 C.F.R. §1.56. Copies of the citations with English-language abstracts are enclosed for the convenience of the Examiner. Each reference cited in this Supplemental IDS was cited in the January 12, 2001 communication from the Japanese Patent Office in a corresponding Japanese Patent Application. U.S. Patent Nos. 5,604,578 and 5,859,778 correspond to Japanese Patent Nos. 08-241019 and 07-288871, respectively.

Certificate of Mailing (37 C.F.R. 1.8)

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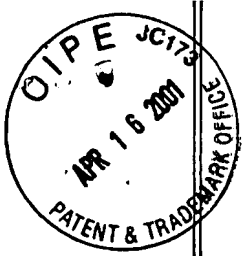
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Applicant intends to provide complete translations of all non-translated foreign references.

This Supplemental IDS is being submitted not more than three months after the attached references were cited by a foreign patent office, and, therefore, no fee is deemed necessary. However, if any fee is required, authorization is hereby given to charge the amount of such fee to Deposit Account No. 19-4709.

Applicant respectfully requests that the Examiner make the enclosed references of record in the subject application. Early and favorable action in connection with this matter is earnestly solicited.

Respectfully submitted,

for: David C. Strout Reg. No. 42,548
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): **Hiroaki Sekizawa**

Docket No.

448563/0157

Serial No.

09/226,332

Filing Date

January 6, 1999

Examiner

Not Yet Assigned

Group Art Unit

2785

Invention: **MACHINE MONITOR SYSTEM, LOCAL MONITOR UNIT, INTEGRATED MONITOR UNIT, MACHINE MONITOR METHOD, AND COMPUTER-READABLE MEDIUM STORING PROGRAM**



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